



INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	Docket No. 52433/820	Application No. 10/551,159	
	Applicant(s) Koki TONAKA et al.	Examiner John J. Zimmerman	
	Filing Date September 28, 2005	Confirmation No. 3164	Art Unit 1794

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	JP 2001-200352	07/24/2001	JP			Abstract	
	JP 2001-288550	10/19/2001	JP			Abstract	
	JP 2001-279412	10/10/2001	JP			Abstract	
	JP 2004-204280	07/22/2004	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated March 23, 2009 issued in corresponding Japanese Application No. 2004-027623
	Japanese Office Action dated December 28, 2008 issued in corresponding Japanese Application No. 2004-027623
	Yanagihara et al., "MATERIA JAPAN" The Japan Institute of Metals, Vol. 39, No. 5 (2000), pgs. 450-455

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	